

**Reply Under 37 CFR 1.116 - Expedited Procedure  
- Technology Center - Art Unit 1753**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: John Commander, et al.      Art Unit: 1753  
Serial No.: 10/091,106  
Filed: March 5, 2002  
Confirmation No.: 5919  
For: DEFECT REDUCTION IN ELECTRODEPOSITED  
COPPER FOR SEMICONDUCTOR APPLICATIONS  
Examiner: Edna Wong

June 5, 2006

**AMENDMENT G AFTER FINAL**

In response to the final Office action dated January 3, 2006, please consider the following amendments and remarks.

Amendments to the claims are reflected in the listing of the claims that begins on page 2 of this paper.

Remarks begin on page 11 of this paper.

Conclusion begins on page 15 of this paper.